

Innovating Energy Technology

Simultaneous Measurement of 7 Components in Flue Gas Gas Analyzer ZSU-7



Monitors up to 7 gas concentrations Simultaneous and continuous measurement of NOx, SO₂, CO, CO₂, O₂, HCI, and dust.

Space-saving design

All the necessary equipment are housed in a cabinet of 1215 (W) x 700 (D) x 1780 (H) mm size.

Less electrical work Signal and power terminals are integrated into one place.

Maintenance-free HCI measurement enabled by laser technology

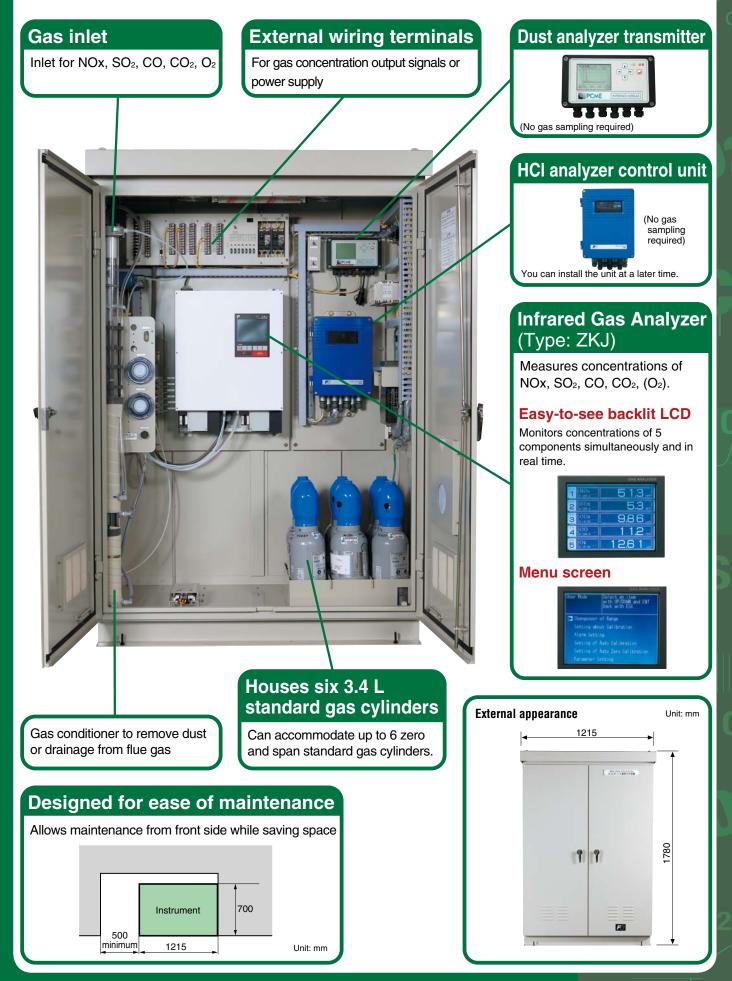
This laser gas analyzer can be installed at a later time. Conforms to JIS B7993 (Automated measuring systems for flue gas using non-extractive methods.)

Energy saving

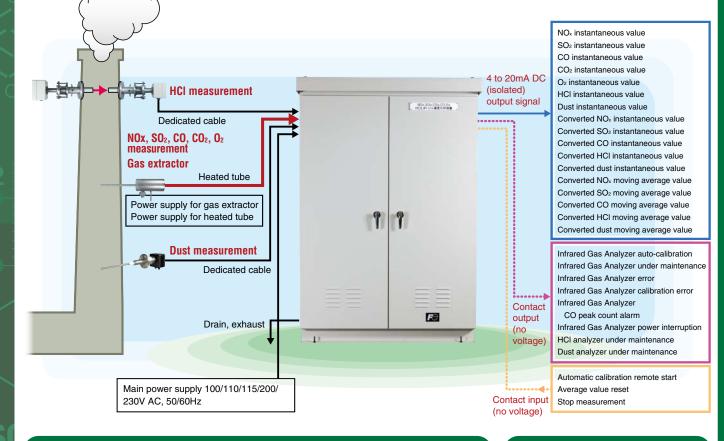
Approx. 40% less power-consumption compared to conventional systems, thanks to the use of laser gas analyzer and by integrating multiple equipment into the cabinet.

Space-saving cabinet contains everything you need

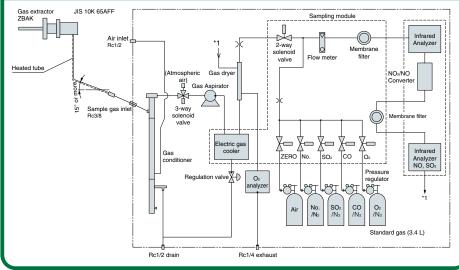
for measuring gas concentration of up to 7 components: NOx, SO2, CO, CO2, O2, HCI, and dust.

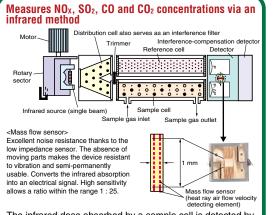


Less electrical work signal and power terminals are in one place!

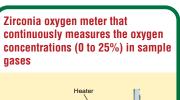


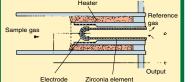
Gas sampling system (for NOx, SO₂, CO, CO₂, O₂)





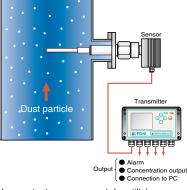
The infrared dose absorbed by a sample cell is detected by the mass flow sensor.





Detects Oxygen concentration by measuring the EMF (electromotive force) generated between the electrodes in the front and rear of the Zirconia element

Laser HCl analyzer Uses an infrared semiconductor laser (CLASS 1) as the light-emitting element, and photodiode as the light-receiving element. Hardly affected by other gases thanks to the use of the absorption wavelength which matches the HCl concentration. No need for gas sampling devices - fast response and low maintenance.



Non-contact measurement- by utilizing electrostatic induction to detect charge transfer of charged particle moving through a duct.

Stable output - advanced circuit eliminates triboelectric current generated by the contact between particles and the probe.

Specifications

Infrared gas analyzer (ZKJ)

Inirared gas analyzer (ZKJ)				
Measurable components and ranges	NOx: 0 to 50 ppm5000 ppm SOz: 0 to 50 ppm5000 ppm CO: 0 to 50 ppm5000 ppm CO: 0 to 50 ppm5000 ppm CO: 0 to 10%/0 to 20% O2: 0 to 10%/0 to 25%			
Measuring principle	Non-dispersive infrared (double beam). Zirconia method for O2 measurement			
Repeatability	±0.5% FS			
Zero drift	±1.0% FS or less per week (±2.0% FS or less per week for the range below 200 ppm) O2 measurement: ±2.0% FS or less per month			
Span drift	±2.0% FS or less per week O2 measurement: ±2.0% FS or less per month			
Gas sampling amount	Approx. 2 L/min			
Response speed	90% response from inlet: within 120 seconds. (SO2 measurement: within 240 seconds.)			
Output signal	4 to 20 mA DC			
Auto calibration	Zero and span (calibration cycle configurable)			
Display	backlit LCD Instantaneous value, O ₂ converted instantaneous value, O ₂ converted average value O ₂ average value, CO peak count value Parameter setting (Japanese or English, as specified)			

Integrated cabinet

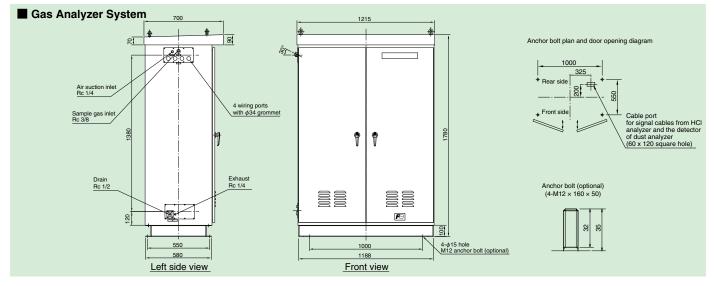
Dimensions	Indoor type: 1215 (W) x 700 (D) x 1780 (H) mm			
Power supply voltage	100/110/115/200/230 V AC, 50/60 Hz, approx. 1200 VA			
Weight	Approx. 500kg			
Output signal	4 to 20 mA DC (isolation signal)			
External contact output	SPST no-voltage contact, up to 8 points (in maintenance status, in auto-calibration status, analyzing section error, CO peak count alarm, etc.)			
External contact input	No-voltage contact (auto-calibration start, average value re- set, measurement stop)			
Computing unit	Calculates moving average and O ₂ corrected gas concen- tration, in dust measurement			
Recorder (option)	Inkjet or paperless			
Ambient temperature	-5 to +40 °C, -10 to + 40°C, or -15 to + 40°C (as specified by order)			
Gas condition	Temperature: 450°C max. Dust: 100 mg/Nm ³ max. Pressure: -5 to +5 kPa Components: SO2: 500 ppm max., NOx: 1000 ppm max. CO2: 0 to 15%, CO: 0 to 2000 ppm, O2: 1 to 21%, HCI: 1000 ppm max.			

Gas extractor					
System	Electric heating system (with 316 SS wire mesh filter, 4				
	μm)				
Gas temperature	Standard: 60 to 800°C (316 SS)				
(probe material)	Optional:1000°C (titanium), 1300°C (Sic)				
Maximatina					
Mounting	JIS 5K 65A flange				
Power consumption	Heated tube: approx. 720 VA per 20 m				
Gas inlet tube	Heated tube (30m max.) or ϕ 10/ ϕ 8 mm Teflon tube				
Laser HCI ana					
Measurable gas	HCI, NH3, O2, HCI + H2O, NH3 + H2O, CO, CO2,				
	CO + CO2, CO + O2				
Principle	Non-dispersive infrared (NDIR)				
Installation	Cross-stack system				
Laser class	CLASS 1M				
Measurement range	15 ppm·m to 5000 ppm·m				
Optical path length	0.5 to 10 m (0.5 to 5 m in CO + O2 measurement)				
(stack diameter)					
Repeatability	±2.0% FS				
Zero drift	±2.0% FS/6 months				
Response speed	1 to 5 seconds				
(90% response)					
Gas temperature	1200°C max.				
	JIS10K 50A flange				
Mounting	Instrument air, pressure ± 10 kPa, flow rate 20 L/min or more				
Mounting Air purge	Instrument air, pressure ± 10 kPa, flow rate 20 L/min or mor				
U	Instrument air, pressure ± 10 kPa, flow rate 20 L/min or mor 100 m max. between transmitter unit and control unit				
Air purge					

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Dust analyzer					
Measuring object	Dust concentration				
Principle	Electrostatic induction				
Measurement range	0.01 to 1000 mg/m ³				
Probe	Gas temperature	Material	Mounting		
	-25°C to +250°C	316 SS (Teflon coating is available as option)	R1·1/2 screw JIS10K 50A flange		
	-25°C to +400°C	Ceramic	JIS10K 50A flange		
	-25°C to +800°C	Ceramic	JIS10K 50A flange		
Probe length	150 mm max.				
Signal cable length	100 m max. between detector and transmitter				
Display	LCD (bar graph, numeric values, trend display)				

Dimensions (unit: mm)



For Fuji Electric Co., Ltd.

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